



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Group Art Unit: 2814

Application No.: 08/930,449

Examiner: S. H. Rao

Filed: October 7, 1997

Docket No.: 039514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed with a Request for Continued Examination under 37 CFR §1.114. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application. A foreign version of the foreign examination report is attached for the Examiner's information.
- ☒ 3. English-language Abstracts of the non-English language references are attached.
- ☒ 4. Computer-generated English translations of the Japanese Patent Publications for references 2 and 5 have been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and are attached, but have not been reviewed for accuracy.

Respectfully submitted,

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JAO:GWT/gwt

Date: June 30, 2004

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Sheet 1 of 1

Form PTO-145 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 039514		APPLICATION NO. 08/930,449	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT(S) Hiroyuki ABE et al.			
				FILING DATE October 7, 1997		GROUP 2814	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1	JP-A 57-194518 w/ Abstract	11/30/1982	Japan			
	2	JP-A 06-026966 w/ Abstract and translation	02/04/1994	Japan			
	3	JP-A 59-054218 w/ Abstract	03/29/1984	Japan			
	4	JP-A 62-031111 w/ Abstract	02/10/1987	Japan			
	5	JP-A 06-333823 w/ Abstract and translation	12/02/1994	Japan			
	6	JP-A 03-011727 w/ Abstract	01/21/1991	Japan			
	7	JP-A 63-093108 w/ Abstract	04/23/1988	Japan			
	8	JP-A 62-116770 w/ Abstract	05/28/1987	Japan			
	9	JP-A 61-188928 w/ Abstract	08/22/1986	Japan			
	10	JP-A 62-003089 w/ Abstract	01/09/1987	Japan			
	11	JP-A 03-289128 w/ Abstract	12/19/1991	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: June 30, 2004